



High-field measurements with kHz repetition rate, microsecond dc pulses

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Conditioning in RF and DC









...courtesy of Xboxes team



Fig. 3. Conditioning curves from tests at Pulsed DC System taken with HRR circuit, 16.7 μ s pulse lengths and 60 μ m gap distances. MeVArc 2018







Pulsed DC System

vacuum system for high-gradient studies

Fig. 4. Pulsed DC system at CERN: a) schematic of the equipment, b) photo of Large Electrodes System (LES), c) 3D-model for LES.



Marx generator



CERM



Fig. 5.1. Photo of Marx generator together with LES.

Repetition rate: up to 6 kHz Pulse length: 500 ns – 1 ms.



Fig. 5.2. The waveforms taken with Marx generator and LES with 1 μ s pulse (0.6 μ s delay is used in BD case).



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Conditioning for different materials

Motivation:

Gain vs Pulses

This algorithm was implemented at Pulsed DC system to be similar to RF test.

The conditioning is needed for training of materials to be able to reached higher electrical field.



Fig. 7. Visualization of conditioning algorithm.

Feedback mode

7

120000

100000





Pulses



Recovering after BD (ramp)



For flat and feedback modes



Motivation:

 $\hfill\square$ To see if we can reduce the time needed for recovering after BD.







Fig. 8.2. Effect of ramp to the results.

8







Conditioning for different materials







BD localization technique





Fig. 11. Visualization of BDs evolution at the surface for **007 Hard Cu** electrodes (video works only in slide show mode (red dots corresponded to BDs occurred at the optimized region.

BD identification





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Surface electric field [MV/m] 0 0 0 0 0 0 0 012 Soft Cu Upper Anode - Initial conditioning 012 Soft Cu Upper Anode • 012 Soft Cu Bottom Anode $imes 10^7$ Pulses

















Pulses

10⁻⁹

×10⁸



Probability density





Fig. 16. a) effect of ramp algorithm to results; b) the example of PDF analysis.



BDR vs Surface electric field



 $BDR \propto E^{30} \tau^5$



No.	Material	Surface Electric Field, MV/m	Power
005	SS CuAg	72.8 – 86.8	40
005	SS CuAg	87.8 – 102	39
006	Nb	65.0 - 89.0	13
006	Nb	75.0 – 103	14
007	Hard Cu	86 - 80	92
007	Hard Cu	85 – 77	54
008	Soft Cu	80 – 72	14
008	Soft Cu	72 – 80	27

Fig. 17. Example of the fitting results for one of the test.



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 $BDR \propto E^{30} \tau^5$

Method of measurement:

Choose voltage for BDR range

Choose pulse width for start.

Change pulse width every N

The tests were done in the

or decreasing order.

(~25 mln or 50 mln) number of

range $0.5 - 128 \,\mu s$ in increasing

Start pulsing with 2 kHz.

1E-4 – 1E-7.

pulses.

BDR vs Pulse width





Fig. 18. Example of the fitting results for one of the test.









 $BDR \propto E^{30} \tau^5$ Table with results from all tests. Sample Voltage [V] **Material** Range Order **BDR range** Power number 007 Hard Cu 0.5 - 64 5.3E-6 - 4.3E-5 0.42 4740 up Hard Cu 007 0.5 - 128 down 4440 4.0E-7 – 1.7E-5 0.82 007 Hard Cu 0.5 - 128 4440 2.4E-7 – 1.3E-5 0.8 up Soft Cu **800** 0.5 - 128 4500 2.8E-7 - 2.2E-5 0.4 up Soft Cu 800 0.5 - 128 down 4500 2.0E-7 – 3.0E-5 0.63 Soft Cu 800 0.5 - 128 4500 2.0E-7 – 3.9E-5 1.01 down Soft Cu 0.5 - 128 800 4500 3.5E-7 – 3.7E-5 0.84 up

More data in Anton talk...



BDR vs Rep Rate



Motivation

To study the effect of Repetition Rate to the BD.

<u>Methods</u>

- •The voltages was chosen to have BDR in reasonable range (1E-5 1E-7).
- •The test were done with different electrodes (started with **005 SS CuAg** electrodes and the last results were taken few weeks ago with **012 Soft Cu**).





Step 1: Initial





Fig. 22. BDR vs different Repetition rates.



Step 1: Initial





For checking how difference in voltage could affect to the BDR, **100 Hz** and **2 kHz** results taken for comparison at next tests.

Fig. 23. BDs vs Pulses during test with different Repetition Rates.



taken with 2 kHz during "a)"; c) separated data taken with 100 Hz during "a)".



Step 3: Calibration









Vin = 500 => Vout = 6396 V

Rep Rate [Hz]	MaxV	AmplV	AvrV	Abs rel 2000 Hz	Rel rel 2000 Hz	Rep Rate [Hz]	MaxV	AmplV	AvrV	Abs rel 2000 Hz	Rel rel 2000 Hz
50	5161	5114	5098	14	0.28%	50	6429	6396	6375	9	0.14%
100	5161	5109	5097	13	0.26%	100	6425	6392	6377	11	0.17%
500	5152	5105	5091	7	0.14%	500	6424	6391	6371	5	0.08%
1000	5144	5097	5087	3	0.06%	1000	6421	6390	6369	3	0.05%
2000	5146	5097	5084	0	0.00%	2000	6425	6389	6366	0	0.00%
2000 3000	5146 5132	5097	5084	0 -12	0.00% -0.24%	2000 3000	6425 6418	6389 6371	6366 6357	0 -9	0.00% -0.14%
2000 3000 4000	5146 5132 5128	5097 5095 5073	5084 5072 5065	0 -12 -19	0.00% -0.24% -0.37%	2000 3000 4000	6425 6418 6407	6389 6371 6363	6366 6357 6344	0 -9 -22	0.00% -0.14% -0.35%
2000 3000 4000 5000	5146 5132 5128 5106	5097 5095 5073 5056	5084 5072 5065 5053	0 -12 -19 -31	0.00% -0.24% -0.37% -0.61%	2000 3000 4000 5000	6425 6418 6407 6399	6389 6371 6363 6354	6366 6357 6344 6336	0 -9 -22 -30	0.00% -0.14% -0.35% 26.47%



Step 4: Swap Rep Rate vs correction





Sample number	Material	Rep Rate F1/F2	V1/V2	#BDs1/ #BDs2	BDR1/ BDR2	Ratio (BDR1/BDR2)
005	SS CuAg		5220/5220	112/16	1.12E-5/1.59E-6	7.04
005	SS CuAg		5220/5220	<mark>60/8</mark>	5.98E-6/7.99E-7	7.48
006	Nb		6000/6000	198/201	3.99E-5/3.43E-6	11.63
006	Nb		6000/6000	255/224	2.66E-5/3.59E-6	7.41
007	Hard Cu		4520/4500	145/138	2.96E-5/1.89E-5	1.57
007	Hard Cu		4440/4460	<mark>87/96</mark>	1.63E-5/1.11E-5	1.47
007	Hard Cu	100/2000	4380/4400	103/102	6.34E-6/3.34E-6	1.9
008	Soft Cu		4780/4800	195/156	1.99E-4/6.56E-5	3.03
008	Soft Cu		4600/4620	130/152	2.28E-5/6.9E-6	3.3
008	Soft Cu		4510/4530	77/83	1.96E-5/7.65E-6	2.56
008	Soft Cu		4450/4570	<mark>89/90</mark>	1.28E-5/7.89E-6	1.62
008	Soft Cu		4400/4420	145/133	1.38E-5/1.29E-6	10.7
004	SS and Cu		3760/3780	59/137	2.11E-6/1.12E-6	1.88



10⁻³

10⁻⁴

10⁻⁵

10⁻⁶

10¹

Error

Error

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BDR





Fig. 27. The overview of the results from several cycles from 10 Hz to 6 kHz with compensation for

CERN



Repetition Rate [Hz]

10³

10²



Step 6: Calibration for final test





Checking the applied correction for 4950 V.

Freq	AvrV	Abs rel 2000 Hz	Rel rel 2000 Hz
10	4925	-1.7	-0.03%
20	4926	-0.4	-0.01%
50	4924	-2.7	-0.05%
100	4923	-3.6	-0.07%
200	4927	0.5	0.01%
500	4928	1.4	0.03%
1000	4930	3.3	0.07%
2000	4926	0.0	0.00%
3000	4929	2.6	0.05%
4000	4926	-0.8	-0.02%
5000	4929	2.6	0.05%
6000	4918	-8.5	-0.17%



Step 7: Additional









Conclusion and future plans

> Two pulsed dc systems are available at CERN for studying conditioning process using different materials and effect of different parameters to BDR. Several tests are now standardized for each set of electrodes to help understanding the effect of the material.

 \succ Correlation of data from different sources (generator, oscilloscope, vacuum gauge, cameras, microscopy) used to find full information for each BD.

Plans:

➢ Provide fresh, half-conditioned and fully conditioned Soft Cu electrodes (for analysis @ Hebrew University of Jerusalem); Any other ideas?

 \succ Test with different gaps;

Dark current measurement during the pulsing and looking for dark current fluctuations.





Extra slides

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PDF without ramp data



BD localization





BD localization during all tests (in blue) and BDs during dark current measurements (in red) for: a) 007 Hard Cu,
b) 009 Soft Cu electrodes. The start of edge at electrodes geometry is shown in green.







Summarized results from several tests with different Rep Rates

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2

1.5

Pulses



З

 $\times 10^{8}$

Conditioning for different materials

006 Nb, 1 μs

2.5

007 Hard Cu, 1 μ s 008 Soft Cu, 1 μ s





Figure 5: Average breakdown fields after conditioning of iridium shown with that of the materials previously tested in [1]. For pure metals, their crystal structures are indicated (fcc = face-centred cubic, bcc = body-centred cubic, hcp = hexagonal closest packing) on the top.

Fig. 36. Comparison of the conditioning for electrodes tested at pulsed DC systems. During all tests the spacer for 60 μ m gap was used, except 002 Hard Cu (100 μ m).

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Surface Electric Field [MV/m]

20

0

0

0.5

120







Initial and final conditioning for Nb





Fig. 23. Comparison of conditioning curves for 006 Nb electrodes.











